

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of
Akira SAKURAI et al.

JC12 Rec'd PCT/PTO 02 MAY 2005

Application No.: New U.S. National Stage of
PCT/JP03/013837

Filed: May 2, 2005

Docket No.: 123653

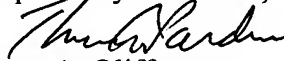
For: A METHOD FOR FORMING A THIN FILM OF SILVER MIRROR AND A METHOD FOR
FORMING A COATED FILM CONTAINING SAID THIN FILM OF SILVER MIRRORINFORMATION DISCLOSURE STATEMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language references 6 and 14 is discussed in the present specification.
- ☒ 3. The references 1-2 and 5-12 were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. English language Abstracts of the non-English language references 3-11 and 13-14 are attached hereto.
- ☒ 6. A computer-generated English language translation of the Japanese Patent Publications 3-8, 10-11 and 13-14 has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy.

Respectfully submitted,


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Date: May 2, 2005
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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 123653		APPLICATION NO. New U.S. National Stage of PCT/JP03/013837	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Akira SAKURAI et al. FILING DATE May 2, 2005			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1)	5,716,433	02/10/1998	AONUMA et al.			
	2)	US 6,398,854 B1	06/04/2002	AONUMA			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	3)	JP A 2000-234175 w/ abst. & trans	08/29/2000	JAPAN			
	4)	JP A 9-87858 w/ abstract & trans	03/31/1997	JAPAN			
	5)	JP A 11-186697 w/ abstract & trans	07/09/1999	JAPAN			
	6)	JP A 2001-46958 w/ abst. & trans	02/20/2001	JAPAN			
	7)	JP A 2000-129452 w/ abst. & trans	05/09/2000	JAPAN			
	8)	JP A 2000-243119 w/ abst. & trans	09/08/2000	JAPAN			
	9)	JP B2 63-34228 w/ abstract	07/08/1988	JAPAN			
	10)	JP A 2000-73178 w/ abst. & trans	03/07/2000	JAPAN			
	11)	JP A 6-49653 w/ abstract & trans	02/22/1994	JAPAN			
	12)	WO 93/10975 A1	06/10/1993	WIPO			
	13)	JP A 6-38860 w/ abstract & trans	02/15/1994	JAPAN			
	14)	JP A 11-335858 w/ abstract & trans	12/07/1999	JAPAN			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: May 2, 2005